



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kyu-Dong JUNG, et al.

Art Unit: 2813

Serial No. 10/701,552

Examiner: Monica D. Harrison

Filed: November 6, 2003

Confirmation No. 8318

FOR: METHOD AND APPARATUS FOR VACUUM-
MOUNTING A MICRO-ELECTRO MECHANICAL
SYSTEM ON A SUBSTRATE

Attorney Docket No. 277/013

AMENDMENT UNDER 37 C.F.R. § 1.114 and
REQUEST FOR PERSONAL INTERVIEW

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir:

INTRODUCTORY COMMENTS

In connection with a concurrently-filed Request for Continued Examination, and in response to the Office Action Made Final, mailed February 22, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of the claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.